

1. Record Nr.	UNINA9910631092103321
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Titolo	Electrokinetic microfluidics and nanofluidics // Dongqing Li
Pubbl/distr/stampa	Cham, Switzerland : , : Springer, , [2023] ©2023
ISBN	9783031161315 9783031161308
Descrizione fisica	1 online resource (288 pages)
Collana	Fluid mechanics and its applications ; ; Volume 133
Disciplina	530.417
Soggetti	Electrokinetics Microfluidics Nanofluids
Lingua di pubblicazione	Inglese
Formato	Materiale a stampa
Livello bibliografico	Monografia
Nota di bibliografia	Includes bibliographical references.
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